

10/501/117

14 JAN 2005

Docket No.: OGOSH19USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/501,117 Confirmation No. 5689
Applicant : Okabe et al.
371 Filed : July 12, 2004
Art Unit :
Examiner :
Customer No. : 00270
Title : COPPER ALLOY SPUTTERING TARGET AND
METHOD FOR MANUFACTURING THE TARGET

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE UNDER 37 CFR 1.8(a)	
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail on the date indicated below in an envelope addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450	
Signature	<i>W. Marden</i>
Date	1/12/05

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In compliance with their duty to disclose under 37 CFR §1.56(a), Applicants and their attorneys enclose a form PTO-1449 and copies of the foreign and other documents listed therein.

The cited references were cited in the International Search Report for International Application No. PCT/JP02/12697. An English language abstract and/or a corresponding U.S. application publication is provided for each Japanese language reference.

The Examiner is respectfully requested to consider the cited documents and to make the same of record in the file of the present application.

In the event that a fee for the Information Disclosure Statement is required, please charge the fee to our Deposit Account No. 08-3040.

Respectfully submitted,
HOWSON AND HOWSON
Attorneys for Applicant

By William Bak
William Bak
Reg. No. 37,277
Spring House Corp. Center
Box 457,
Spring House, PA 19477
(215) 540-9216

Form PTO-1449 U.S. Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT	Atty. Docket No. OGOSH19USA	Serial No. 10/501,117
	Applicant: Okabe et al.	
	371 (c) Date: July 12, 2004	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Subclass
	2004/0004288 A1	1/2004	Sekiguchi	257	758
	2002/0024142 A1	2/2002	Sekiguchi	257	758

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation Yes No
	JP 2002-075995	3/2002	Japan	See "Sekiguchi" above
	JP 2000-239836	9/2000	Japan	Abstract only x
	JP 10-330927	12/1998	Japan	Abstract only x
	JP 49-23127	3/1974	Japan	Abstract only x

Other Documents (including Author, Title, Date, Pertinent Pages, Etc.)

	Patent Abstracts of Japan, 1 page English Abstract of JP 2002-075995, 3/2002
	Patent Abstracts of Japan, 1 page English Abstract of JP 2000-239836, 9/2000
	Patent Abstracts of Japan, 1 page English Abstract of JP 10-330927, 12/1998
	Derwent, 1 page English Abstract of JP 49-23127, 3/1974
Examiner	Date Considered

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.